

Form PTO-1449 (Modified)

LIST OF PATENTS AND PUBLICATIONS
FOR APPLICANT'S
INFORMATION DISCLOSURE STATEMENT
(Use several sheets if necessary)

Atty Docket No.:
G0228

Serial No.: 09 955,517

Applicant: Fabery, *et al.*

Filing Date: 9 18 01

Group: 1746

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date
A						
B						

RECEIVED #3
FEB 04 2002
TC 1700

FOREIGN PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation
						Yes No
C						
D						

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

pt	F	—	Gerold, David J., <i>et al.</i> Multiple Patch Transmission and Phase Analysis of Six Types of Strong Phase-Shifting Masks. Pgs. 1-15
pt	F	—	Neureuther, Andrew R. <i>Formability and Inspection Issues of Phase Objects in Phase-Shifting Masks</i> . http://buffy.eecs.berkeley.edu/IRO/Summary/01abstracts/kadam1.html Pgs. 1-3. Last viewed on July 20, 2001
pt	G	—	Niu, X., <i>et al.</i> Specular Spectroscopic Scatterometry in DUV Lithography. Timbre Technology, Inc., <i>et al.</i>

EXAMINER

P. Hernandez

DATE CONSIDERED

4-2-03

EXAMINER: Initial of reference considered, whether or not citation is in conformance with MPEP 2112. Drawings through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.
S. HAM AND p753us p7149-01d